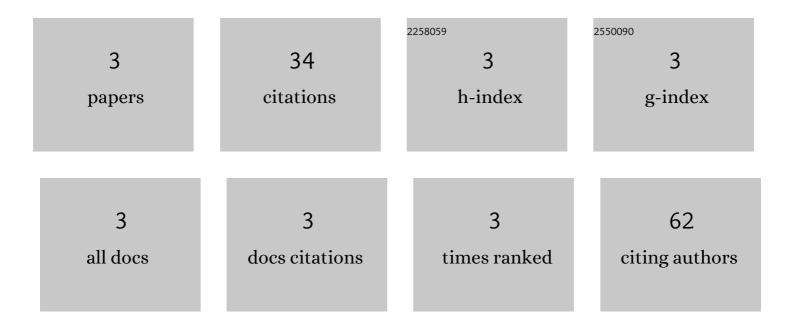
## Joel Fridmann

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/493747/publications.pdf Version: 2024-02-01



#	Article	IF	CITATIONS
1	Low-temperature, site selective graphitization of SiC via ion implantation and pulsed laser annealing. Applied Physics Letters, 2012, 100, .	3.3	19
2	Materials modifications using a multi-ion beam processing and lithography system. Nuclear Instruments & Methods in Physics Research B, 2012, 272, 153-157.	1.4	11
3	Synthesis of graphene and graphene nanostructures by ion implantation and pulsed laser annealing. Journal of Applied Physics, 2016, 120, .	2.5	4